

**Search Notes**

Application/Control No.

10/659,624

Examiner

Paul D. Kim

Applicant(s)/Patent under  
Reexamination

GOUO, AKIO

Art Unit

3729

**SEARCHED**

Class	Subclass	Date	Examiner
29	603.03 603.05 603.06	7/21/2005	PK
324	210 212	7/28/2005	PK
360	244.1 244.2	↓	
	245.8		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
PGPub Text Search See attachment		1/31/2006	PK

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/748,918 US PAT. 6,690,546	7/21/2005	PK
Text Search EAST/NPL (IEEE)	7/21/2005	PK
Consulted by David Shindler (324)	7/28/2005	PK
Consulted by Criag Renner (360)	7/28/2006	PK
Updated Text Search EAST	7/28/2006	PK
PGPub Text Search EAST	1/31/2006	PK